

# WEST Search History

DATE: Thursday, May 25, 2006

Hide?	Set Name	Query	Hit Count
		<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L22	L21 not l16	24
<input type="checkbox"/>	L21	L20 same (current collector or collecting plate)	43
<input type="checkbox"/>	L20	L19 same (film or layer or layer\$3 or coat or coat\$3)	151306
<input type="checkbox"/>	L19	((silicon or Si) near2 oxide)	201026
<input type="checkbox"/>	L18	L17 not l16	16
<input type="checkbox"/>	L17	L15 same ((silicon or Si) near2 oxide)	35
<input type="checkbox"/>	L16	L15 with ((silicon or Si) near2 oxide)	19
<input type="checkbox"/>	L15	(film or layer or layer\$3 or coat or coat\$3) with (current collector or collecting plate)	9217
<input type="checkbox"/>	L14	L13 not l12	28
<input type="checkbox"/>	L13	((silicon or Si) near2 oxide) same (current collector or collecting plate)	50
<input type="checkbox"/>	L12	((silicon or Si) near2 oxide) with (current collector or collecting plate)	22
<input type="checkbox"/>	L11	L10 not l9	9
<input type="checkbox"/>	L10	L7 same (current collector or collecting plate)	28
<input type="checkbox"/>	L9	L8 not l1	19
<input type="checkbox"/>	L8	L7 with (current collector or collecting plate)	19
<input type="checkbox"/>	L7	((silicon or Si) near2 oxide) with (film or layer or layer\$3 or coat or coat\$3)	136677
<input type="checkbox"/>	L6	(current collector or collecting plate) same ((film or layer or layer\$3 or coat or coat\$3) near2 (alloy or alloy\$3)) same ((silicon or Si) near2 oxide)	0
<input type="checkbox"/>	L5	L4 not l1	21
<input type="checkbox"/>	L4	(current collector or collecting plate) same ((film or layer or layer\$3 or coat or coat\$3) near2 (alloy or alloy\$3)) same (silicon or silicon oxide)	31
<input type="checkbox"/>	L3	L1 and ((silicon or Si) near2 oxide)	0
<input type="checkbox"/>	L2	(current collector or collecting plate) with ((film or layer or layer\$3 or coat or coat\$3) near2 (alloy or alloy\$3)) with ((silicon or Si) near2 oxide)	0
<input type="checkbox"/>	L1	(current collector or collecting plate) with ((film or layer or layer\$3 or coat or coat\$3) near2 (alloy or alloy\$3)) with (silicon or silicon oxide)	10

END OF SEARCH HISTORY

## Refine Search

### Search Results -

Term	Documents
(21 NOT 16).PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD.	24
(L21 NOT L16 ).PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD.	24

Database:

US Pre-Grant Publication Full-Text Database  
 US Patents Full-Text Database  
 US OCR Full-Text Database  
 EPO Abstracts Database  
 JPO Abstracts Database  
 Derwent World Patents Index  
 IBM Technical Disclosure Bulletins

Search:

L22

Refine Search

Recall Text

Clear

Interrupt

### Search History

DATE: Thursday, May 25, 2006   [Printable Copy](#)   [Create Case](#)

<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>	<u>Set</u> <u>Name</u> result set
side by side			
<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>			
<u>L22</u>	L21 not l16	24	<u>L22</u>
<u>L21</u>	L20 same (current collector or collecting plate)	43	<u>L21</u>
<u>L20</u>	L19 same (film or layer or layer\$3 or coat or coat\$3)	151306	<u>L20</u>
<u>L19</u>	((silicon or Si) near2 oxide)	201026	<u>L19</u>
<u>L18</u>	L17 not l16	16	<u>L18</u>
<u>L17</u>	L15 same ((silicon or Si) near2 oxide)	35	<u>L17</u>
<u>L16</u>	L15 with ((silicon or Si) near2 oxide)	19	<u>L16</u>
<u>L15</u>	(film or layer or layer\$3 or coat or coat\$3) with (current collector or collecting plate)	9217	<u>L15</u>
<u>L14</u>	L13 not l12	28	<u>L14</u>
<u>L13</u>	((silicon or Si) near2 oxide) same (current collector or collecting plate)	50	<u>L13</u>
<u>L12</u>	((silicon or Si) near2 oxide) with (current collector or collecting plate)	22	<u>L12</u>
<u>L11</u>	L10 not l9	9	<u>L11</u>
<u>L10</u>	L7 same (current collector or collecting plate)	28	<u>L10</u>

<u>L9</u>	L8 not l1	19	<u>L9</u>
<u>L8</u>	L7 with (current collector or collecting plate)	19	<u>L8</u>
<u>L7</u>	((silicon or Si) near2 oxide) with (film or layer or layer\$3 or coat or coat\$3)	136677	<u>L7</u>
<u>L6</u>	(current collector or collecting plate) same ((film or layer or layer\$3 or coat or coat\$3) near2 (alloy or alloy\$3)) same ((silicon or Si) near2 oxide)	0	<u>L6</u>
<u>L5</u>	L4 not l1	21	<u>L5</u>
<u>L4</u>	(current collector or collecting plate) same ((film or layer or layer\$3 or coat or coat\$3) near2 (alloy or alloy\$3)) same (silicon or silicon oxide)	31	<u>L4</u>
<u>L3</u>	L1 and ((silicon or Si) near2 oxide)	0	<u>L3</u>
<u>L2</u>	(current collector or collecting plate) with ((film or layer or layer\$3 or coat or coat\$3) near2 (alloy or alloy\$3)) with ((silicon or Si) near2 oxide)	0	<u>L2</u>
<u>L1</u>	(current collector or collecting plate) with ((film or layer or layer\$3 or coat or coat\$3) near2 (alloy or alloy\$3)) with (silicon or silicon oxide)	10	<u>L1</u>

END OF SEARCH HISTORY